



PFR[®] -800 AUS[®] SR1 (Trial # 64329)

FC 用現像型ソルダーレジストドライフィルム

Dry Film Solder Mask for Flip Chip Substrate Application



主な特徴 Feature

- **投影露光 / DI 露光対応**
Product line up suitable to various exposure units (Projection, LDI multi)
- **高 Tg / 低 CTE 材 : 優れた TCT/PCT 耐性**
Tough resin structure with High Tg/Low CTE for TCT and PCT resistance
- **高精細での優れた電気特性**
Electrical reliability: No migration failure with L/S=15/10 μm after 200hrs, 12V, 130°C/85%Rh
- **徹底した粗粒管理**
Strict control on particle size: Max.particle size <10 μm Majority part is sub-micron order

仕様 Specification

膜厚 Resin thickness	20 μm (standard) - Adjustable
色調 Color	Green
保管条件 Storage condition	Below -15°C
推奨硬化条件 Recommended curing condition	160°C, 60min.

特性 Properties

ガラス移転点 Tg *TMA method	130 - 140 °C
線膨張係数 CTE	α 1 40 - 45 ppm
弾性率 Young's modulus	3.5 - 4.0 GPa
破壊強度 Tensile strength	70 - 75 MPa
破壊伸び率 Elongation	3.5 - 4.0 %
感度 Photosensitivity	350 mJ/cm ²
解像性 SRO resolution	50 μm in diameter
PCT 耐性 (121°C, 2.1atm, 100%Rh, 200hrs)	No peering
HAST 耐性 (130°C, 85%Rh, 12V, 168hrs, L/S=15/10 μm)	No migration
TCT 耐性 (-65 ⇄ 150°C, 1000cycles)	Pass

